

IVS - 2003
22nd IVS Annual Conference and Technical Workshop

To be held on:
Wednesday, October 22, 2003
Dan Hotel, Tel Aviv

IVS-Conference Secretariat

Yehudit Rousso
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**ORGANIZING AND
PROGRAM COMMITTEE**

Rosenwaks, Y., TAU
(Chairman)
Bloch, J., NRC
Galun, U., El Op
Grossman, E., Soreq
Grunbaum, E., TAU
Hamawi, D., NRC
Paz, Y., IIT
Roth, M., HU
Rappaport, M., HIT

The conference will include a joint plenary and the following sessions:

- Thin films, Electronic and Optoelectronic Devices (TF)
- Nanomaterials (NM)
- Surface Science and Technology (SS)
- Mems
- Space Technology (SPT)
- Energy Storage and Conversion (ES)
- Vacuum Technology (VT)
- Crystal Growth And Epitaxy (CG)

Call for Papers

Abstracts for both oral and poster contributions are invited for all sessions.

The Annual assembly of the IVS will take place during the meeting.

Extensive commercial vendor exhibition on site.

Traditional student poster competition.

Important Dates:

Abstracts due:	Sep. 12, 2003
Confirmation of acceptance:	Sep. 22, 2003
Pre-registration:	Sep. 22, 2003

Registration and IVS Membership Form

Registration fees below include entrance to all sessions, book of abstracts, coffee breaks, lunch, and membership to the IVS for the year 2003.

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	Regular (NIS)	Student/Pensioner (NIS)
Until 18/9/03	400	120
After 18/9/03	500	200

To renew membership only, please fill form below and submit with remittance, (80 NIS regular, 40 NIS student/pensioner) with phrase: "IVS year 2003 membership"

Name: _____
Address _____
Email _____
Phone _____

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For room capacity considerations, please mark your daily preference of session:
____NM ____SPT ____CG ____MEMS ____VT ____TF ____ES ____SS

Enclosed is a check, or commitment to pay from your institution (please add 10% processing fee for payment by institutional commitment), for the sum of _____.

NOTE: Cancellations made by Oct. 15 will receive 50% refund. After this date, no refunds can be made.

Instructions for submission of abstracts

Camera ready one page (A4 format with 1 inch space on all 4 sides). The presenting author's name should be underlined, and the email of the corresponding author should be included.

Presentation preference (Circle one): Poster or Oral

Students wishing to participate in the poster or oral competition, please mention it in your abstract submission.

Abstracts should be sent as a Microsoft Word file e-mail attachment to:
Yehudit Rousso <yehudit.rousso@weizmann.ac.il>

Address

Please send the registration form to:
Yehudit Rousso, the IVS secretariat, Dept. of Materials & Interfaces, Weizmann Institute of Science, Rehovot 76100. Tel: 08-9343353, Fax: 08-9344137, E-mail: yehudit.rousso@weizmann.ac.il